

The documentation and process conversion measures necessary to comply with this document shall be completed by 5 October 2004.

INCH POUND

MIL-PRF-19500/701A
5 July 2004
SUPERSEDING
MIL-PRF-19500/701
10 April 2002

* PERFORMANCE SPECIFICATION SHEET

SEMICONDUCTOR DEVICE, FIELD EFFECT RADIATION HARDENED
(TOTAL DOSE AND SINGLE EVENT EFFECTS)
TRANSISTOR, N-CHANNEL, SILICON, TYPES 2N7491T2, 2N7492T2, AND 2N7493T2,
JANTXVR, F, G, AND H AND JANSR, F, G, AND H

This specification is approved for use by all Departments and Agencies of the Department of Defense.

- * The requirements for acquiring the product described herein shall consist of this specification sheet and MIL-PRF-19500.

1. SCOPE

1.1 Scope. This specification covers the performance requirements for a N-Channel, enhancement-mode, MOSFET, radiation hardened (total dose and Single Event Effects (SEE)), power transistor. Two levels of product assurance are provided for each device type as specified in MIL-PRF-19500, with avalanche energy maximum rating (E_{AS}) and maximum avalanche current (I_{AS}).

1.2 Physical dimensions. See figure 1, (TO-205AF).

- * 1.3 Maximum ratings. $T_A = +25^\circ\text{C}$, unless otherwise specified.

Type	P_T (1) $T_C = +25^\circ\text{C}$	P_T $T_A = +25^\circ\text{C}$	$R_{\theta JC}$ Max	V_{DS}	V_{DG}	V_{GS}	I_{D1} (2) (3) $T_C = +25^\circ\text{C}$	I_{D2} (2) (3) $T_C = +100^\circ\text{C}$	I_S	I_{DM} (4)	T_J and T_{STG}
	<u>W</u>	<u>W</u>	<u>°C/W</u>	<u>V dc</u>	<u>V dc</u>	<u>V dc</u>	<u>A dc</u>	<u>A dc</u>	<u>A dc</u>	<u>A (pk)</u>	<u>°C</u>
2N7491T2	25	0.71	5	30	30	± 20	12	10	12	48	-55
2N7492T2	25	0.71	5	60	60	± 20	12	9.5	12	48	to
2N7493T2	25	0.71	5	100	100	± 20	11.7	7.4	11.7	46.8	+150

- (1) Derate linearly 0.2 W/°C for $T_C > +25^\circ\text{C}$.
(2) The following formula derives the maximum theoretical I_D limit. I_D is limited by package and device construction to 12 Amps.

$$I_D = \sqrt{\frac{T_{JM} - T_C}{(R_{\theta JC}) \times (R_{DS(on)} \text{ at } T_{JM})}}$$

- (3) See figure 2, maximum drain current graphs.
(4) $I_{DM} = 4 \times I_{D1}$; I_{D1} as calculated by note (2).

* Comments, suggestions, or questions on this document should be addressed to Defense Supply Center, Columbus, ATTN: DSCC-VAC, P.O. Box 3990, Columbus, OH 43218-3990, or emailed to Semiconductor@dsccl.dla.mil. Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at <http://www.dodssp.daps.mil/>.

* 1.4 Primary electrical characteristics at $T_C = +25^\circ\text{C}$.

Type	Min $V_{(BR)DSS}$ $V_{GS} = 0$ $I_D = 1.0\text{mA}$ dc	$V_{GS(TH)1}$ $V_{DS} \geq V_{GS}$ $I_D = 1.0\text{ mA}$ dc		Max I_{DSS1} $V_{GS} = 0$ $V_{DS} = 80$ percent of rated V_{DS}	Max $r_{DS(on)}$ (1) $V_{GS} = 12\text{V}, I_D = I_{D2}$		E_{AS}
					$T_J = +25^\circ\text{C}$	$T_J = +150^\circ\text{C}$	
	<u>V dc</u>	<u>V dc</u>		<u>$\mu\text{A dc}$</u>	<u>Ω</u>	<u>Ω</u>	<u>mJ</u>
		Min	Max				
2N7491T2	30	2.0	4.0	10	0.045	0.100	520
2N7492T2	60	2.0	4.0	10	0.048	0.110	270
2N7493T2	100	2.0	4.0	10	0.080	0.184	173

(1) Pulsed (see 4.5.1).

2. APPLICABLE DOCUMENTS

* 2.1 General. The documents listed in this section are specified in sections 3, 4, or 5 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3, 4, or 5 of this specification, whether or not they are listed.

2.2 Government documents.

* 2.2.1 Specifications, standards, and handbooks. The following specifications, standards, and handbooks form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

* DEPARTMENT OF DEFENSE SPECIFICATIONS

MIL-PRF-19500 - Semiconductor Devices, General Specification for.

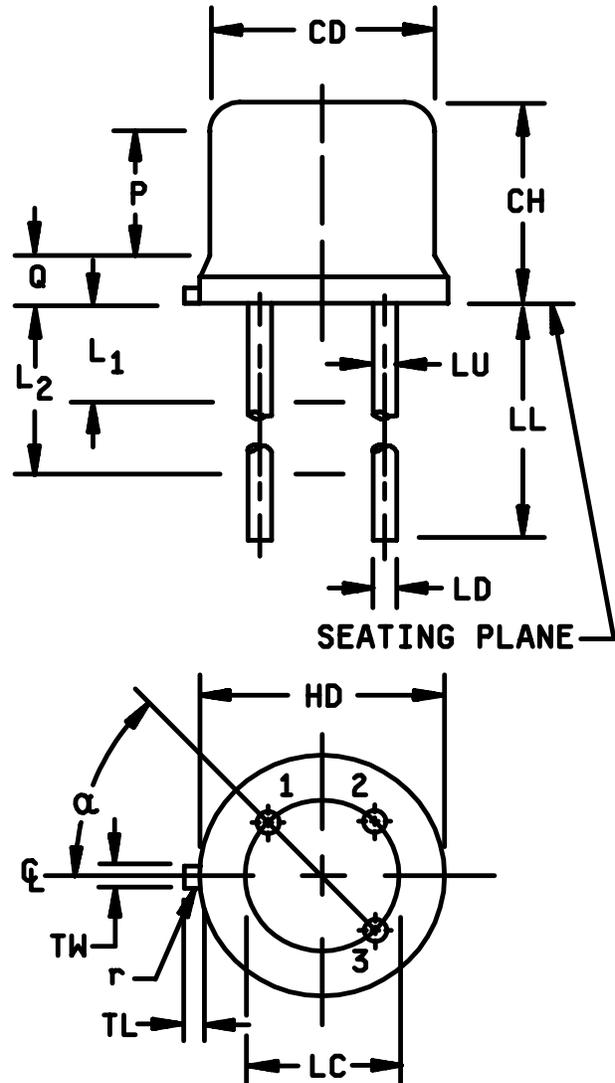
* DEPARTMENT OF DEFENSE STANDARDS

MIL-STD-750 - Test Methods for Semiconductor Devices.

* (Copies of these documents are available online at <http://assist.daps.dla.mil/quicksearch/> or <http://www.dodssp.daps.mil/> or from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

2.3 Order of precedence. In the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

Symbol	Dimensions			
	Inches		Millimeters	
	Min	Max	Min	Max
CD	.315	.355	8.00	9.02
CH	.160	.180	4.06	4.57
HD	.340	.370	8.64	9.39
LC	.200 BSC		5.08 BSC	
LD	.016	.021	0.41	0.53
LL	.500	.750	12.70	19.05
LU	.016	.019	0.41	0.48
L ₁		.050		1.27
L ₂	.250		6.35	
P	.070		1.78	
Q		.050		1.27
TL	.029	.045	0.74	1.14
TW	.028	.034	0.71	0.86
α	45° BSC			
Term 1	Source			
Term 2	Gate			
Term 3	Drain			



NOTES:

1. Dimensions are in inches.
- * 2. Millimeters are given for general information only.
3. Lead number 1 is the source, lead number 2 is the gate, lead number 4 is omitted from this outline. The drain is number 3 and is electrically connected to the case.
- * 4. In accordance with ASME Y14.5M, diameters are equivalent to ϕ x symbology.

* FIGURE 1. Physical dimensions for TO-205AF.

3. REQUIREMENTS

* 3.1 General. The individual item requirements shall be as specified in MIL-PRF-19500 and as modified herein.

3.2 Qualification. Devices furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturer's list (QML) before contract award (see 4.2 and 6.3).

* 3.3 Abbreviations, symbols, and definitions. Abbreviations, symbols, and definitions used herein shall be as specified in MIL-PRF-19500 and as follows:

I_{AS} - Rated avalanche current, nonrepetitive
nC - nano Coulomb

3.4 Interface and physical dimensions. Interface and physical dimensions shall be as specified in MIL-PRF-19500, and on figure 1 (TO-205AF).

3.4.1 Lead finish. Lead finish shall be solderable in accordance with MIL-PRF-19500, MIL-STD-750, and herein. Where a choice of lead finish is desired, it shall be specified in the acquisition document (see 6.2).

3.5 Marking. Marking shall be in accordance with MIL-PRF-19500. At the option of the manufacturer, marking of the country of origin may be omitted from the body of the transistor but shall be retained on the initial container.

3.6 Electrostatic discharge protection. The devices covered by this specification require electrostatic discharge protection.

3.6.1 Handling. MOS devices must be handled with certain precautions to avoid damage due to the accumulation of static charge. However, the following handling practices are recommended (see 3.6).

- a. Devices should be handled on benches with conductive handling devices.
- b. Ground test equipment, tools, and personnel handling devices.
- c. Do not handle devices by the leads.
- d. Store devices in conductive foam or carriers.
- e. Avoid use of plastic, rubber, or silk in MOS areas.
- f. Maintain relative humidity above 50 percent if practical.
- g. Care should be exercised during test and troubleshooting to apply not more than maximum rated voltage to any lead.
- h. Gate must be terminated to source, $R \leq$ or 100 k Ω , whenever bias voltage is applied drain to source.

* 3.7 Electrical performance characteristics. Unless otherwise specified herein, the electrical performance characteristics are as specified in 1.3, 1.4, and table I.

* 3.8 Electrical test requirements. The electrical test requirements shall be as specified in table I.

3.9 Workmanship. Semiconductor devices shall be processed in such a manner as to be uniform in quality and shall be free from other defects that will affect life, serviceability, or appearance.

4. VERIFICATION

4.1 Classification of inspections. The inspection requirements specified herein are classified as follows:

- a. Qualification inspection (see 4.2).
- b. Screening (see 4.3).
- c. Conformance inspection (see 4.4 and tables I and II).

4.2 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-19500 and as specified herein. Alternate flow is allowed for qualification inspection in accordance with figure 4 of MIL-PRF-19500.

* 4.2.1 Group E qualification. Group E inspection shall be performed for qualification or re-qualification only. In case qualification was awarded to a prior revision of the specification sheet that did not request the performance of table III tests, the tests specified in table III herein that were not performed in the prior revision shall be performed on the first inspection lot of this revision to maintain qualification.

4.2.1.1 SEE. Design capability shall be tested on the initial qualification and thereafter whenever a major die design or process change is introduced. See the design safe operation area figures herein.

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* 4.3 Screening (JANS and JANTXV). Screening shall be in accordance with table IV of MIL-PRF-19500, and as specified herein. The following measurements shall be made in accordance with table I herein. Devices that exceed the limits of table I herein shall not be acceptable.

Screen (see table IV of MIL-PRF-19500) (1) (2)	Measurement	
	JANS	JANTXV
(3)	Gate stress test (see 4.3.1)	Gate stress test (see 4.3.1)
(3)	Method 3470 of MIL-STD-750, single pulse avalanche energy test (see 4.3.2)	Method 3470 of MIL-STD-750, single pulse avalanche energy test (see 4.3.2)
(3) 3c	Method 3161 of MIL-STD-750, thermal impedance (see 4.3.3)	Method 3161 of MIL-STD-750, thermal impedance (see 4.3.3)
7	Optional.	Optional.
9	Subgroup 2 of table I herein I_{DSS1} , I_{GSSF1} , I_{GSSR1} , as a minimum	Not applicable
10	Method 1042 of MIL-STD-750, test condition B	Method 1042 of MIL-STD-750, test condition B
11	I_{GSSF1} , I_{GSSR1} , I_{DSS1} , $r_{DS(ON)1}$, $V_{GS(TH)1}$ Subgroup 2 of table I herein. $\Delta I_{GSSF1} = \pm 20$ nA dc or ± 100 percent of initial value, whichever is greater. $\Delta I_{GSSR1} = \pm 20$ nA dc or ± 100 percent of initial value, whichever is greater. $\Delta I_{DSS1} = \pm 10$ μ A dc or ± 100 percent of initial value, whichever is greater.	I_{GSSF1} , I_{GSSR1} , I_{DSS1} , $r_{DS(ON)1}$, $V_{GS(TH)1}$ Subgroup 2 of table I herein.
12	Method 1042 of MIL-STD-750, test condition A	Method 1042 of MIL-STD-750, test condition A
13	Subgroups 2 and 3 of table I herein $\Delta I_{GSSF1} = \pm 20$ nA dc or ± 100 percent of initial value, whichever is greater. $\Delta I_{GSSR1} = \pm 20$ nA dc or ± 100 percent of initial value, whichever is greater. $\Delta I_{DSS1} = \pm 10$ μ A dc or ± 100 percent of initial value, whichever is greater. $\Delta r_{DS(ON)1} = \pm 20$ percent of initial value. $\Delta V_{GS(TH)1} = \pm 20$ percent of initial value.	Subgroups 2 and 3 of table I herein $\Delta I_{GSSF1} = \pm 20$ nA dc or ± 100 percent of initial value, whichever is greater. $\Delta I_{GSSR1} = \pm 20$ nA dc or ± 100 percent of initial value, whichever is greater. $\Delta I_{DSS1} = \pm 10$ μ A dc or ± 100 percent of initial value, whichever is greater. $\Delta r_{DS(ON)1} = \pm 20$ percent of initial value. $\Delta V_{GS(TH)1} = \pm 20$ percent of initial value.
14	Required	Required

(1) At the end of the test program, I_{GSSF1} , I_{GSSR1} , and I_{DSS1} are measured.

(2) An out-of-family program to characterize I_{GSSF1} , I_{GSSR1} , I_{DSS1} , and $V_{GS(th)1}$ shall be invoked.

(3) Shall be performed anytime before screen 9.

* 4.3.1 Gate stress test. Apply $V_{GS} = 24$ V minimum for $t = 250$ μ s minimum.

* 4.3.2 Single pulse avalanche energy (E_{AS}).

- a. Peak current, $I_{AS} = I_{D1}$.
- b. Inductance, $L = (2 * E_{AS} / (I_{D1})^2) * ((V_{BR} - V_{DD}) / V_{BR})$ mH minimum.
- c. Gate to source resistor, R_{GS} : $25 \Omega \leq R_{GS} \leq 200 \Omega$.
- d. Supply voltage, $V_{DD} = 25$ V dc, except $V_{DD} = 50$ V dc for 2N7493T2.
- e. Initial case temperature, $T_C = +25^\circ$ C, -5° C, $+10^\circ$ C.
- f. Gate voltage, $V_{GS} = 12$ V dc.
- g. Number of pulses to be applied: 1 pulse minimum.

* 4.3.3 Thermal impedance ($Z_{\theta JC}$ measurement). The $Z_{\theta JC}$ measurement (or equivalent ΔV_{SD} measurement) shall be performed in accordance with method 3161 of MIL-STD-750. The maximum limit (not to exceed figure 3, thermal impedance curves and the table I, subgroup 2 limits) for $Z_{\theta JC}$ in screening (table IV of MIL-PRF-19500) shall be derived by each vendor by means of statistical process control. When the process has exhibited control and capability, the capability data shall be used to establish the fixed limit. In addition to screening, once a fixed limit has been established, monitor all future sealing lots using a random five piece sample from each lot, to be plotted on the applicable X bar R chart. If a lot exhibits an out of control condition, the entire lot shall be removed from the line and held for engineering evaluation and disposition. This procedure may be used in lieu of an in line process monitor.

- a. Measuring current (I_M) 10 mA.
- b. Drain heating current (I_H) 1.39 A.
- c. Heating time (t_H) 10 ms.
- d. Drain-source heating voltage (V_H) 12 V.
- e. Measurement time delay (t_{MD}) 30 - 60 μ s.
- f. Sample window time (t_{SW}) 10 μ s maximum.

* 4.4 Conformance inspection. Conformance inspection shall be in accordance with MIL-PRF-19500.

4.4.1 Group A inspection. Group A inspection shall be conducted in accordance with table V of MIL-PRF-19500 and table I herein.

* 4.4.2 Group B inspection. Group B inspection shall be conducted in accordance with the conditions specified for subgroup testing in table VIa (JANS) and in table VIb (JANTXV) of MIL-PRF-19500, and as follows. Electrical measurements (end-points) shall be in accordance with table I, subgroup 2 herein.

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4.4.2.1 Group B inspection, table VIa (JANS) of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
B3	1051	Test condition G, 100 cycles.
B3	2077	SEM (scanning electron microscope).
B4	1042	Intermittent operation life, condition D, 2,000 cycles. No heat sink or forced-air cooling on the device shall be permitted during the on cycle. $t_{on} = 30$ seconds minimum.
B5	1042	Accelerated steady-state gate bias, condition B, $V_{GS} = \text{rated}$; $T_A = +175^\circ\text{C}$, $t = 24$ hours minimum; or $T_A = +150^\circ\text{C}$, $t = 48$ hours minimum.
B5	1042	Accelerated steady-state reverse bias, condition A, $V_{DS} = \text{rated}$; $T_A = +175^\circ\text{C}$, $t = 120$ hours minimum; or $T_A = +150^\circ\text{C}$, $t = 240$ hours minimum.
* B5	2037	Bond strength , test condition A.
B6	3161	See 4.5.2.

4.4.2.2 Group B inspection, table VIb (JANTXV) of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
B2	1051	Test condition G, 25 cycles.
B3	1042	Intermittent operation life, condition D, 2,000 cycles. No heat sink or forced-air cooling on the device shall be permitted during the on cycle. $t_{on} = 30$ seconds minimum.
B5 and B6		Not applicable.

4.4.3 Group C inspection. Group C inspection shall be conducted in accordance with the conditions specified for subgroup testing in table VII of MIL-PRF-19500 and as follows. Electrical measurements (end-points) shall be in accordance with table I, subgroup 2 herein.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
C2	2036	Terminal strength is not applicable.
* C5	3161	See 4.5.2.
* C6	1042	Intermittent operation life, condition D, 6,000 cycles. No heat sink or forced-air cooling on the device shall be permitted during the on cycle. $t_{on} = 30$ seconds minimum.

4.4.4 Group D inspection. Group D inspection shall be conducted in accordance with table VIII of MIL-PRF-19500 and table II herein.

* 4.4.5 Group E inspection. Group E inspection shall be conducted in accordance with the conditions specified for subgroup testing in appendix E, table IX of MIL-PRF-19500 and as specified herein. Electrical measurements (end-points) shall be in accordance with table I, subgroup 2 herein.

4.5 Methods of inspection. Methods of inspection shall be as specified in the appropriate tables and as follows.

4.5.1 Pulse measurements. Conditions for pulse measurement shall be as specified in section 4 of MIL-STD-750.

4.5.2 Thermal resistance. Thermal resistance measurements shall be performed in accordance with method 3161 of MIL-STD-750. The maximum limit of $R_{\theta JC} = 5.0^{\circ}\text{C/W}$. The following parameters shall apply:

- a. Measuring current (I_M) 10 mA
- b. Drain heating current (I_H) 1.39 A
- c. Heating time (t_H) Steady-state (see method 3161 of MIL-STD-750).
- d. Drain-source heating voltage (V_H) 12 V
- e. Measurement time delay (t_{MD}) 30 to 60 μs
- f. Sample window time (t_{SW}) 10 μs maximum

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* TABLE I. Group A inspection.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limits		Unit
	Method	Condition		Min	Max	
<u>Subgroup 1</u>						
Visual and mechanical inspection	2071					
<u>Subgroup 2</u>						
* Thermal impedance <u>2/</u>	3161	See 4.3.3	$Z_{\theta JC}$		1.05	°C/W
Breakdown voltage drain to source 2N7491T2 2N7492T2 2N7493T2	3407	$V_{GS} = 0$, $I_D = 1$ mA dc, bias condition C	$V_{(BR)DSS}$	30 60 100		V dc V dc V dc
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS}$, $I_D = 1$ mA dc	$V_{GS(TH)1}$	2.0	4.0	V dc
* Gate current	3411	$V_{GS} = +20$ V dc, bias condition C, $V_{DS} = 0$	I_{GSSF1}		+100	nA dc
* Gate current	3411	$V_{GS} = -20$ V dc, bias condition C, $V_{DS} = 0$	I_{GSSR1}		-100	nA dc
Drain current	3413	$V_{GS} = 0$, bias condition C, $V_{DS} = 80$ percent of rated V_{DS} ,	I_{DSS1}		10	μA dc
Static drain to source On-state resistance 2N7491T2 2N7492T2 2N7493T2	3421	$V_{GS} = 12$ V dc, condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)1}$		0.045 0.048 0.080	Ω Ω Ω
Forward voltage	4011	$V_{GS} = 0$, condition A, pulsed (see 4.5.1), $I_D = I_{D1}$	V_{SD}		1.5	V dc

See footnotes at end of table.

* TABLE I. Group A inspection - Continued.

Inspection 1/	MIL-STD-750		Symbol	Limits		Unit
	Method	Condition		Min	Max	
<u>Subgroup 3</u>						
High temperature operation		$T_C = T_J = +125^\circ\text{C}$				
Gate current	3411	$V_{GS} = \pm 20\text{V dc}$, bias condition C, $V_{DS} = 0$	I_{GSS2}		± 200	nA dc
Drain current	3413	$V_{GS} = 0$, bias condition C, $V_{DS} = 80$ percent of rated V_{DS}	I_{DSS2}		25	$\mu\text{A dc}$
Static drain to source on-state resistance	3421	$V_{GS} = 12\text{V dc}$, condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)3}$			
2N7491T2					0.090	Ω
2N7492T2					0.096	Ω
2N7493T2					0.160	Ω
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS}$, $I_D = 1\text{ mA dc}$	$V_{GS(TH)2}$	1.0		V dc
Low temperature operation		$T_C = T_J = -55^\circ\text{C}$				
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS(TH)3}$, $I_D = 1\text{ mA dc}$	$V_{GS(TH)3}$		5.0	V dc
<u>Subgroup 4</u>						
Forward transconductance	3475	$I_D = I_{D2}$, $V_{DD} = 15\text{ V dc}$ (see 4.5.1)	g_{FS}			
2N7491T2				12		S
2N7492T2				12		S
2N7493T2				8.7		S
* Switching time test	3472	$I_D = I_{D1}$, $V_{GS} = 12\text{ V dc}$, $R_G = 7.5\ \Omega$, $V_{DD} = 50$ percent of rated V_{DS}				
Turn-on delay time			$t_{D(on)}$		25	ns
Rise time			t_r		100	ns
Turn-off delay time			$t_{D(off)}$		35	ns
Fall time			t_f		30	ns

See footnotes at end of table.

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* TABLE I. Group A inspection - Continued.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limits		Unit
	Method	Condition		Min	Max	
<u>Subgroup 5</u>						
Safe operating area test (high voltage)	3474	See figure 4 $t_p = 10$ ms min. $V_{DS} = 80$ percent of max. rated V_{DS}				
Electrical measurements		See table I, subgroup 2				
<u>Subgroup 6</u>						
Not applicable						
<u>Subgroup 7</u>						
* Gate charge	3471	Condition B. $I_D = I_{D1}$, $V_{GS} = 12$ V dc, $V_{DD} = 50$ percent of rated V_{DS}				
On-state gate charge 2N7491T2			$Q_{G(ON)}$	65	nC	
2N7492T2				40	nC	
2N7493T2				50	nC	
Gate to source charge 2N7491T2			Q_{GS}	20	nC	
2N7492T2				10	nC	
2N7493T2				7.4	nC	
Gate to drain charge 2N7491T2			Q_{GD}	10	nC	
2N7492T2				15	nC	
2N7493T2				20	nC	
* Reverse recovery time	3473	$di/dt = -100$ A/ μ s, $V_{DD} \leq 50$ V $I_D = I_{D1}$	t_{rr}			
2N7491T2				92	ns	
2N7492T2				100	ns	
2N7493T2				202	ns	

1/ For sampling plan, see MIL-PRF-19500.

* 2/ This test required for the following end-point measurements only (not intended for screen 9, 11, or 13):
 Group B, subgroups 2 and 3 (JANTXV).
 Group B, subgroups 3 and 4 (JANS).
 Group C, subgroup 6.
 Group E, subgroup 1.

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* TABLE II. Group D inspection.

Inspection <u>1/ 2/ 3/</u>	MIL-STD-750		Symbol	Pre-irradiation limits		Post-irradiation limits				Unit
	Method	Conditions		R, F, G and H		R, F and G		H <u>4/</u>		
				Min	Max	Min	Max	Min	Max	
<u>Subgroup 1</u> Not applicable										
<u>Subgroup 2</u>		$T_C = +25^\circ\text{C}$								
Steady-state total dose irradiation (VGS bias) <u>5/</u>	1019	$V_{GS} = 12\text{ V}; V_{DS} = 0$								
Steady-state total dose irradiation (VDS bias) <u>5/</u>	1019	$V_{GS} = 0; V_{DS} = 80\text{ percent of rated } V_{DS} \text{ (preirradiation)}$								
End-point electricals:										
Breakdown voltage, drain to source	3407	$V_{GS} = 0; I_D = 1\text{ mA};$ bias condition C	$V_{(BR)DSS}$							
2N7491T2				30		30		30		V dc
2N7492T2				60		60		60		V dc
2N7493T2				100		100		100		V dc
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS}$ $I_D = 1\text{ mA}$	$V_{GS(th)1}$	2.0	4.0	2.0	4.0	1.5	4.0	V dc
Gate current	3411	$V_{GS} = +20\text{ V}; V_{DS} = 0,$ bias condition C	I_{GSSF1}		100		100		100	nA dc
Gate current	3411	$V_{GS} = -20\text{ V}; V_{DS} = 0$ bias condition C	I_{GSSR1}		-100		-100		-100	nA dc
* Drain current	3413	$V_{GS} = 0, V_{DS} = 80\text{ percent of rated } V_{DS}$ (preirradiation) bias condition C	I_{DSS}		10		10		25	$\mu\text{A dc}$
Static drain to source on-state voltage	3405	$V_{GS} = 12\text{ V}; I_D = I_{D2}$ condition A pulsed (see 4.5.1)	$V_{DS(on)}$							
2N7491T2					0.240		0.240		0.300	V dc
* 2N7492T2					0.323		0.323		0.408	V dc
2N7493T2					0.474		0.474		0.592	V dc
Forward voltage source drain diode	4011	$V_{GS} = 0; I_D = I_{D1}$ bias condition C	V_{SD}		1.5		1.5		1.5	V dc

1/ For sampling plan see MIL-PRF-19500

2/ Group D qualification may be performed prior to lot formation. Wafers qualified to these group D QCI requirements may be used for any other specification sheet utilizing the same die design.

3/ At the manufacturer's option, group D samples need not be subjected to the screening tests, and may be assembled in it's qualified package or in any qualified package that the manufacturer has data to correlate the performance to the designated package.

4/ The H designation represents devices which pass end-points at all 100K, 300K and 600K rads (Si).

5/ Separate samples shall be pulled for each bias.

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* TABLE III. Group E inspection (all quality levels) for qualification or re-qualification only.

Inspection	MIL-STD-750		Qualification and large lot quality conformance inspection
	Method	Conditions	
<u>Subgroup 1</u>			12 devices c = 0
Temperature cycling	1051	Test condition G, 500 cycles	
Hermetic seal Fine leak Gross leak	1071	Test conditions G or H Test conditions C or D	
Electrical measurements		See table I, subgroup 2	
<u>Subgroup 2 1/</u>			12 devices c = 0
Steady-state gate bias	1042	Test condition B; 1,000 hours	
Electrical measurements		See table I, subgroup 2	
Steady-state reverse bias	1042	Test condition A; 1,000 hours	
Electrical measurements		See table I, subgroup 2	
<u>Subgroup 3</u>			3 devices, c = 0
DPA			
<u>Subgroup 4</u>			Sample size N/A
Thermal impedance curves		Each supplier shall submit their qual-lot average and design maximum thermal impedance curves. In addition, the optimal test conditions and $Z_{\theta JX}$ limit shall be provided to the qualifying activity in the qualification report	
<u>Subgroup 5</u>			
Not applicable			
<u>Subgroup 6</u>			
ESD	1020	Not required for devices classified as ESD class 1.	
<u>Subgroup 8</u>			22 devices c = 0
Commutating diode for safe operating area test procedure for measuring dv/dt during reverse recovery of power MOSFET transistors or insulated gate bipolar transistors	3476		

See footnotes at end of table.

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* TABLE III. Group E inspection (all quality levels) - for qualification or re-qualification only - Continued.

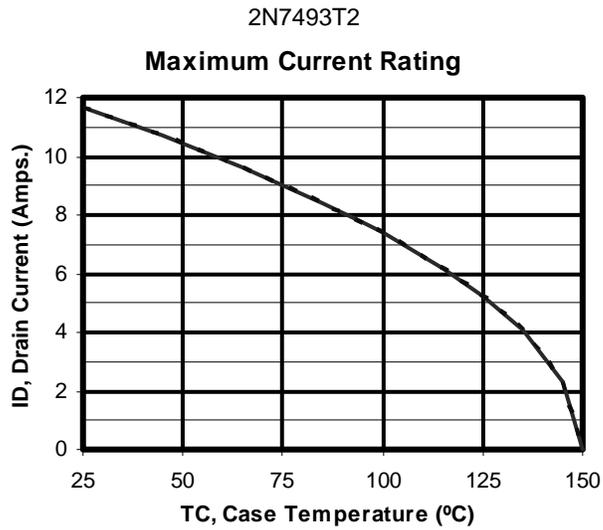
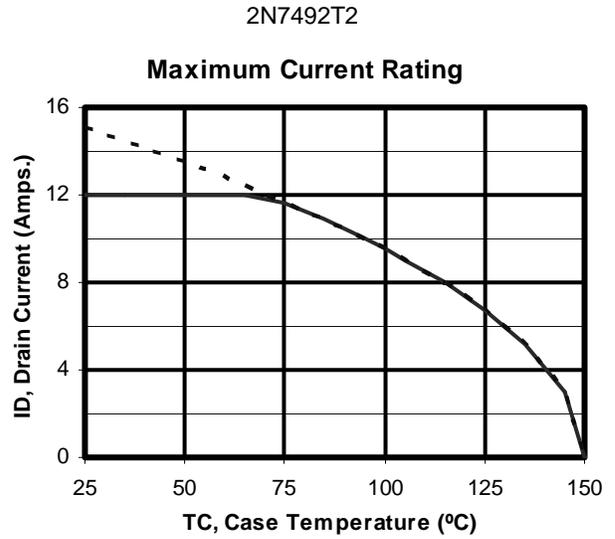
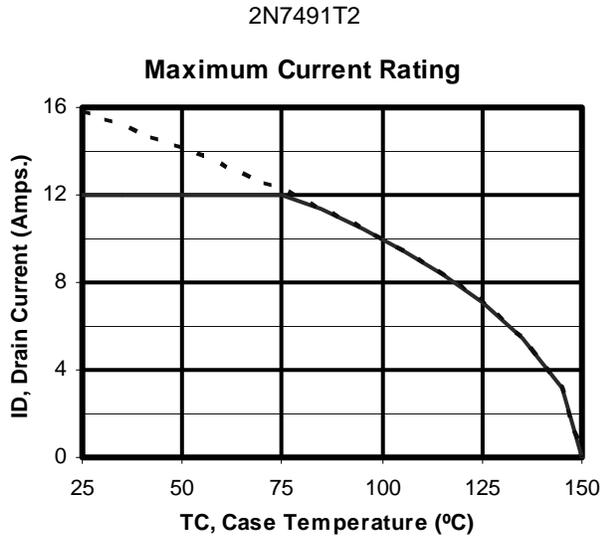
Inspection	MIL-STD-750		Qualification and large lot quality conformance inspection
	Method	Conditions	
<u>Subgroup 9</u>			3 devices
SEE <u>2/ 3/ 4/</u> Electrical measurements <u>5/</u> SEE irradiation	1080	See figure 5. I_{GSSF1} , I_{GSSR1} , and I_{DSS1} in accordance with table I, subgroup 2 Fluence = $3E5 \pm 20$ percent ions/cm ² Flux = $2E3$ to $2E4$ ions/cm ² /sec, temperature = 25 ± 5 °C	
2N7491T2		LET = 28 MeV-cm ² /mg, range = 40 microns, Energy = 261 MeV Insitu bias conditions: $V_{DS} = 30$ V & $V_{GS} = -10$ V $V_{DS} = 25$ V & $V_{GS} = -15$ V $V_{DS} = 15$ V & $V_{GS} = -20$ V	
2N7492T2		LET = 37 MeV-cm ² /mg, range = 37 microns, Energy = 285 MeV Insitu bias conditions: $V_{DS} = 60$ V & $V_{GS} = -15$ V $V_{DS} = 40$ V & $V_{GS} = -20$ V	
2N7493T2		LET = 37 MeV-cm ² /mg, range = 39 microns, Energy = 305 MeV Insitu bias conditions: $V_{DS} = 100$ V & $V_{GS} = -20$ V	
2N7491T2		LET = 37 MeV-cm ² /mg, range = 37microns, Energy = 285 MeV Insitu bias conditions: $V_{DS} = 30$ V & $V_{GS} = -10$ V $V_{DS} = 22.5$ V & $V_{GS} = -15$ V $V_{DS} = 15$ V & $V_{GS} = -20$ V	
2N7492T2		LET = 63 MeV-cm ² /mg, range = 29 microns, Energy = 300 MeV Insitu bias conditions: $V_{DS} = 46$ V & $V_{GS} = -5$ V $V_{DS} = 35$ V & $V_{GS} = -10$ V $V_{DS} = 25$ V & $V_{GS} = -15$ V $V_{DS} = 15$ V & $V_{GS} = -20$ V	
2N7493T2		LET = 60 MeV-cm ² /mg, range = 32 microns, Energy = 340 MeV Insitu bias conditions: $V_{DS} = 100$ V & $V_{GS} = -10$ V $V_{DS} = 35$ V & $V_{GS} = -15$ V $V_{DS} = 25$ V & $V_{GS} = -20$ V	
2N7491T2		LET = 60 MeV-cm ² /mg, range = 33 microns, Energy = 344 MeV Insitu bias conditions: $V_{DS} = 25$ V & $V_{GS} = -5$ V $V_{DS} = 20$ V & $V_{GS} = -10$ V $V_{DS} = 15$ V & $V_{GS} = -15$ V $V_{DS} = 7.5$ V & $V_{GS} = -20$ V	

See footnotes at end of table.

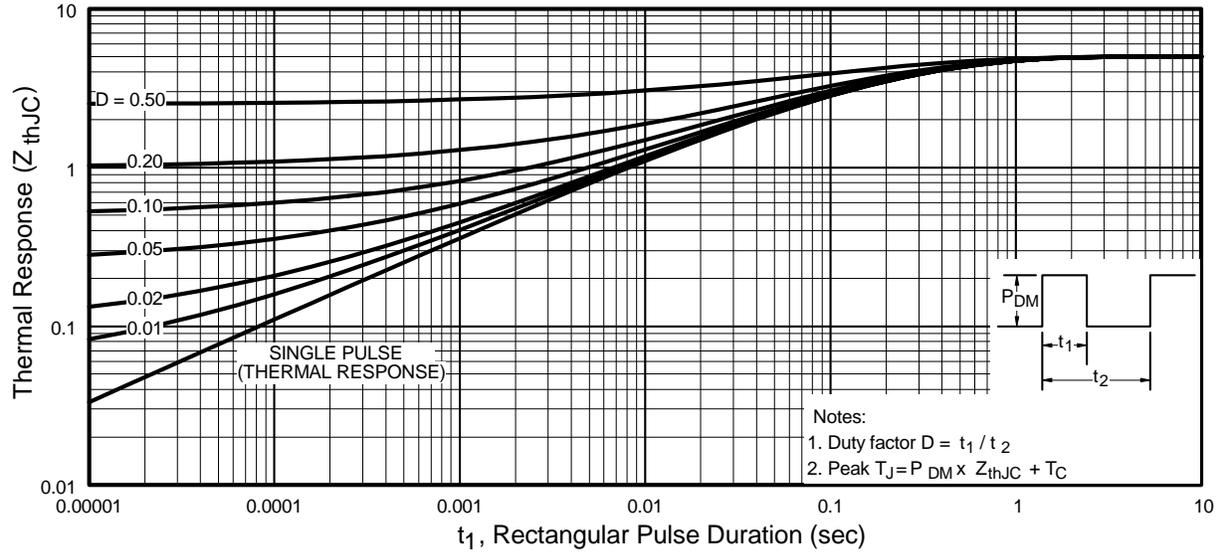
* TABLE III. Group E inspection (all quality levels) - for qualification or re-qualification only - Continued.

Inspection	MIL-STD-750		Qualification and large lot quality conformance inspection
	Method	Conditions	
<u>Subgroup 9-</u> continued 2N7492T2 2N7493T2 Electrical measurements <u>5/</u>		LET = 87 MeV-cm ² /mg, range = 106 microns, Energy = 2068 MeV Insitu bias conditions: V _{DS} = 35 V & V _{GS} = -5 V V _{DS} = 27 V & V _{GS} = -10 V V _{DS} = 20 V & V _{GS} = -15 V V _{DS} = 14 V & V _{GS} = -20 V LET = 82 MeV-cm ² /mg, range = 28 microns, Energy = 350 MeV Insitu bias conditions: V _{DS} = 100 V & V _{GS} = -8 V V _{DS} = 80 V & V _{GS} = -10 V V _{DS} = 25 V & V _{GS} = -15 V I _{GSSF1} , I _{GSSR1} , and I _{DSS1} in accordance with table I, subgroup 2	3 devices

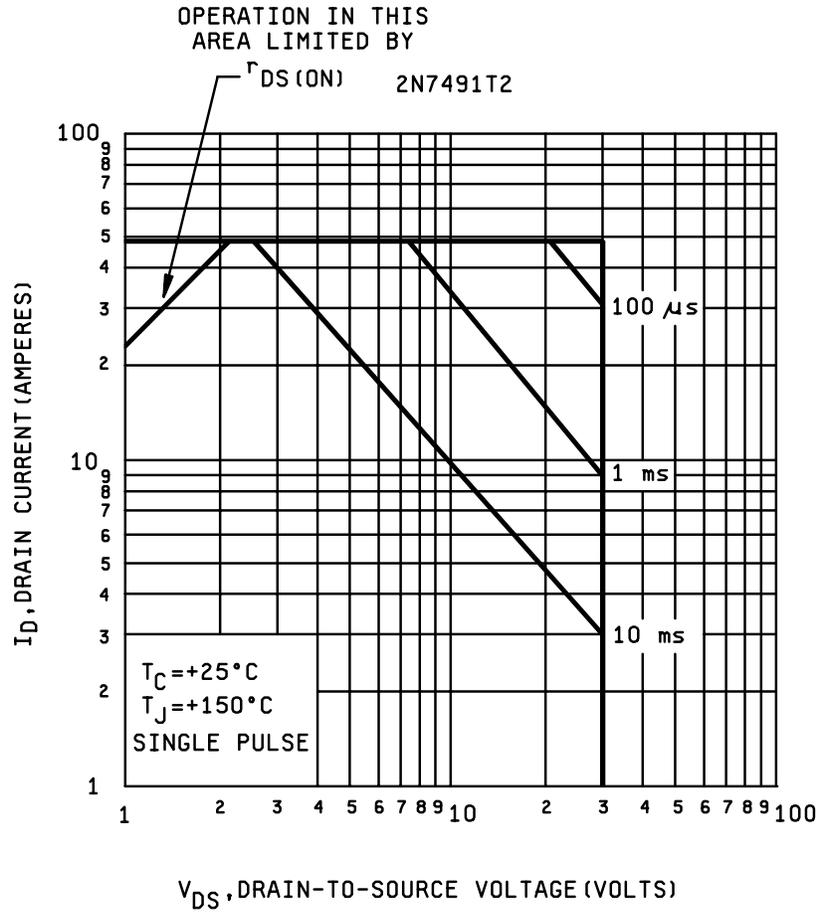
- 1/ A separate sample for each test shall be pulled.
- 2/ Group E qualification of SEE testing may be performed prior to lot formation. Qualification may be extended to other specification sheets utilizing the same structurally identical die design.
- 3/ Device qualification to a higher level LET is sufficient to qualify all lower level LET's.
- 4/ The sampling plan applies to each bias condition.
- 5/ Examine I_{GSSF1}, I_{GSSR1} and I_{DSS1} before and following SEE irradiation to determine acceptability for each bias condition. Other test conditions in accordance with table I, subgroup 2, may be performed at the manufacturer's option.



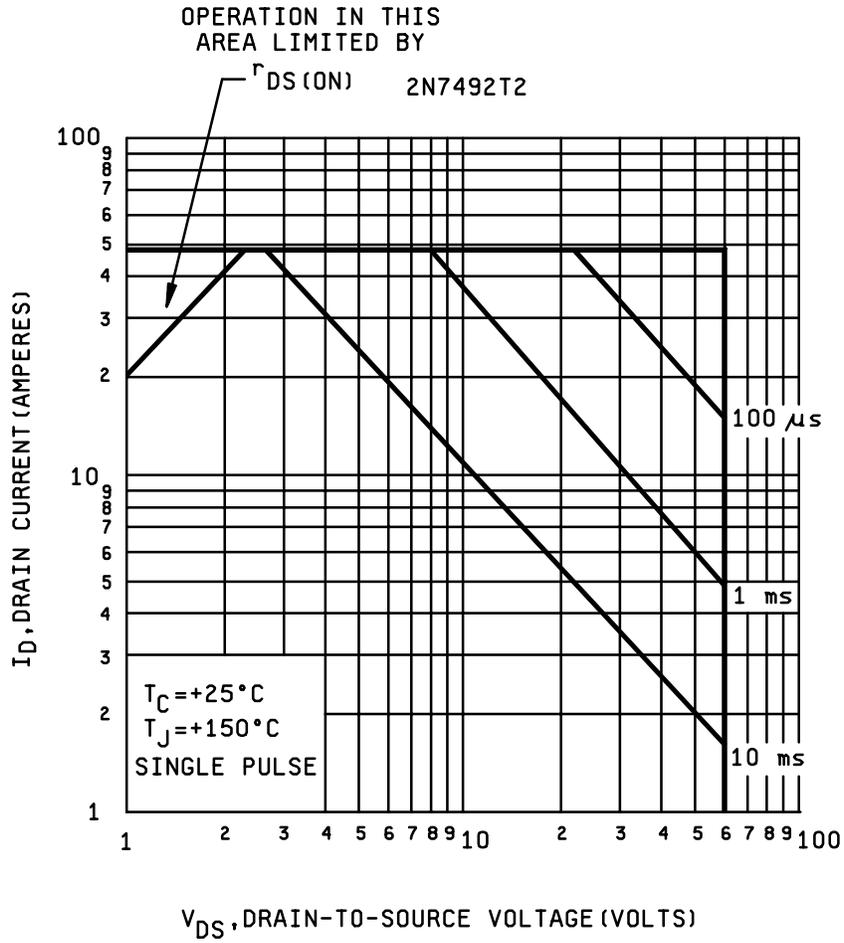
* FIGURE 2. Maximum drain current vs case temperature graphs.



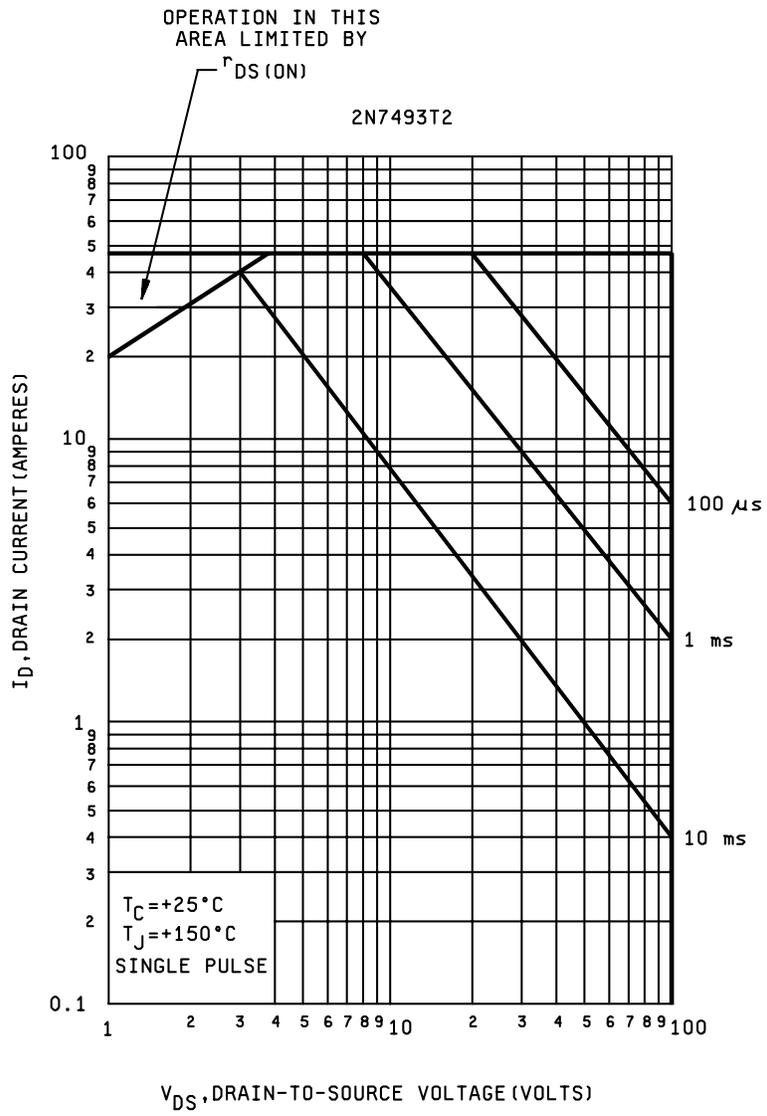
* FIGURE 3. Thermal impedance curve.



* FIGURE 4. Safe operating area graphs.

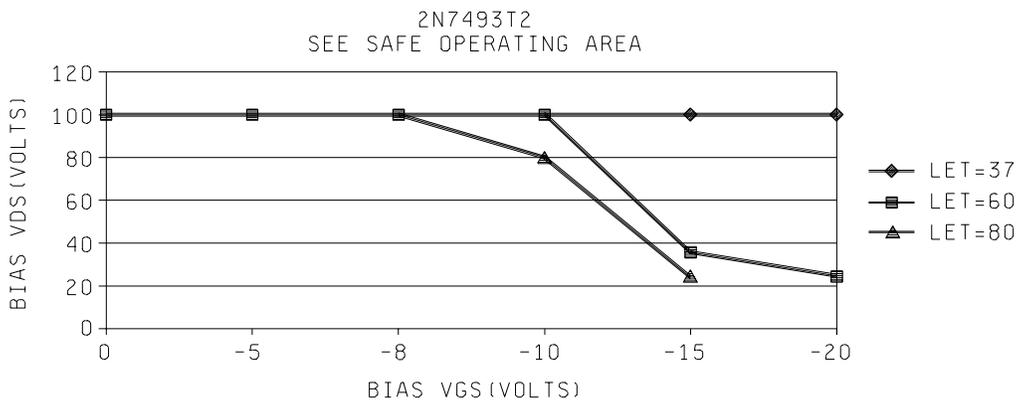
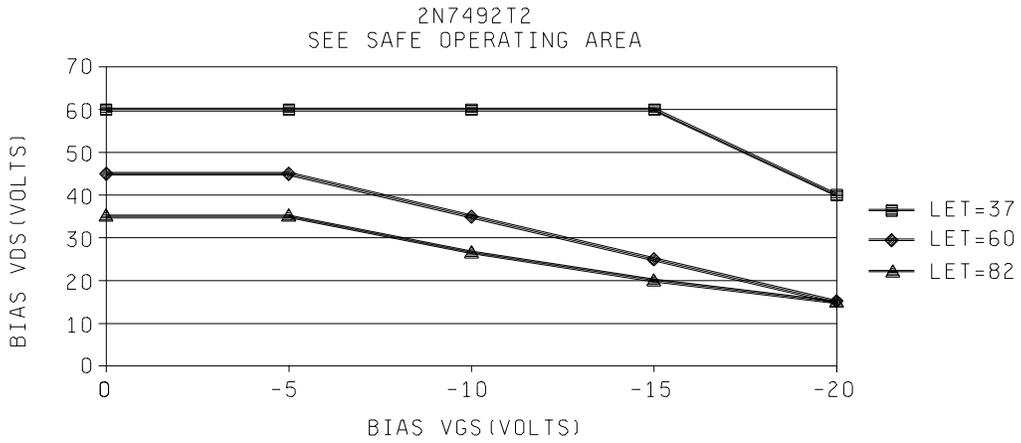
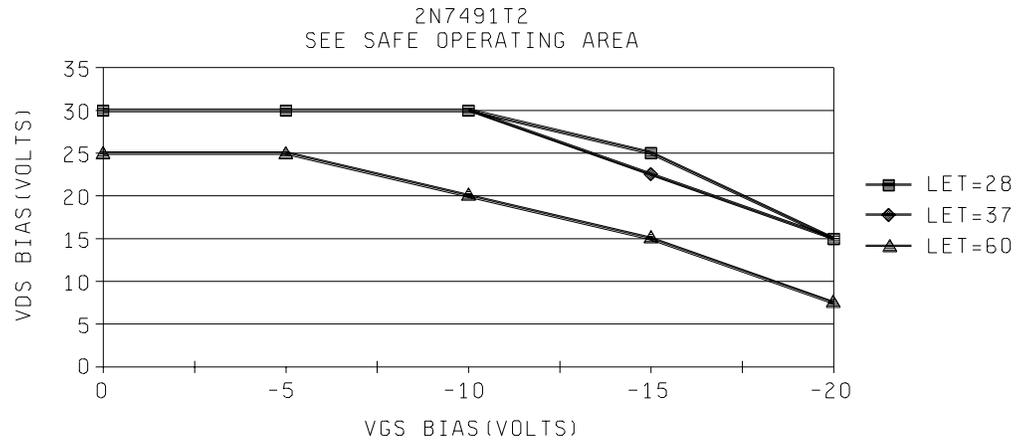


* FIGURE 4. Safe operating area graphs - Continued.



* FIGURE 4. Safe operating area graphs - Continued.

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* FIGURE 5. SEE safe operating area graphs.

5. PACKAGING

* 5.1 Packaging. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When actual packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activities within the Military Service or Defense Agency, or within the Military Service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory.)

6.1 Intended use. The notes specified in MIL-PRF-19500 are applicable to this specification.

* 6.2 Acquisition requirements. Acquisition documents should specify the following:

- a. Title, number, and date of this specification.
- b. Packaging requirements (see 5.1).
- c. Lead finish (see 3.4.1).
- d. Product assurance level and type designator.

6.3 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List (QML 19500) whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from Defense Supply Center, Columbus, ATTN: DSCC/VQE, P.O. Box 3990, Columbus, OH 43218-3990 or e-mail vqe.chief@dla.mil.

6.4 Cross-reference list. The following table shows the generic P/N and its associated military P/N (without JAN and RHA prefix).

Generic P/N	Military P/N
IRHF57Z30	2N7491T2
IRHF57034	2N7492T2
IRHF57130	2N7493T2

* 6.5 Changes from previous issue. The margins of this specification are marked with asterisks to indicate where changes from the previous issue were made. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

Custodians:

Army - CR
Navy - EC
Air Force - 11
NASA - NA
DLA - CC

Preparing activity:
DLA - CC

(Project 5961-2865)

Review activities:

Army - MI
Air Force - 71, 99

* NOTE: The activities listed above were interested in this document as of the date of this document. Since organizations and responsibilities can change, you should verify the currency of the information above using the ASSIST Online database at <http://www.dodssp.daps.mil/> .